

FIG 4

【書類名】

【図1】

図面

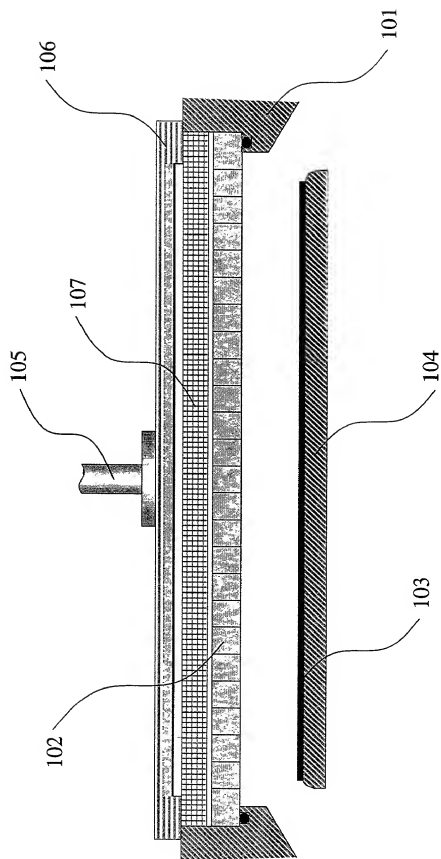


Fig 2

【图2】

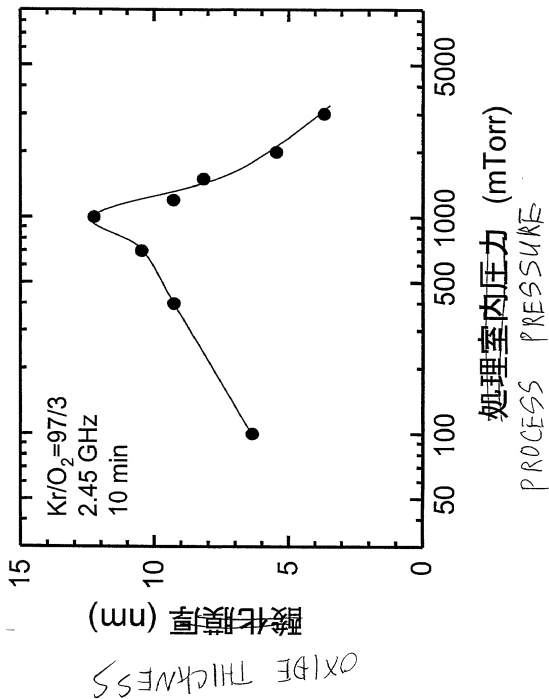
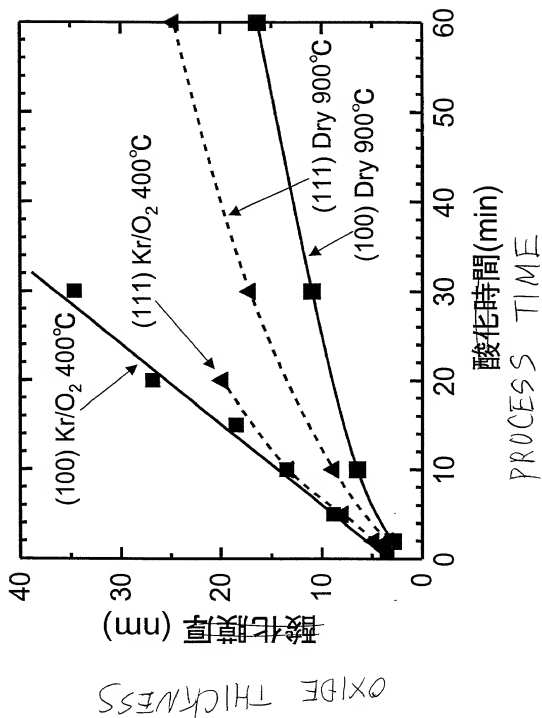


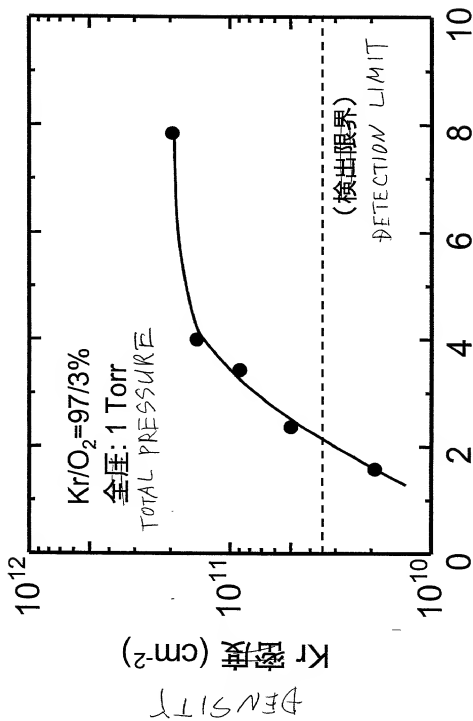
FIG 3

【図3】



ALG 4

【図4】



【图5】

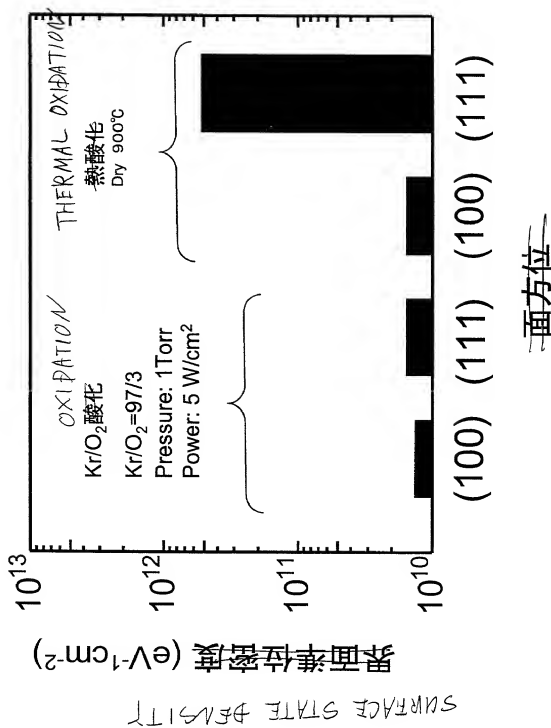
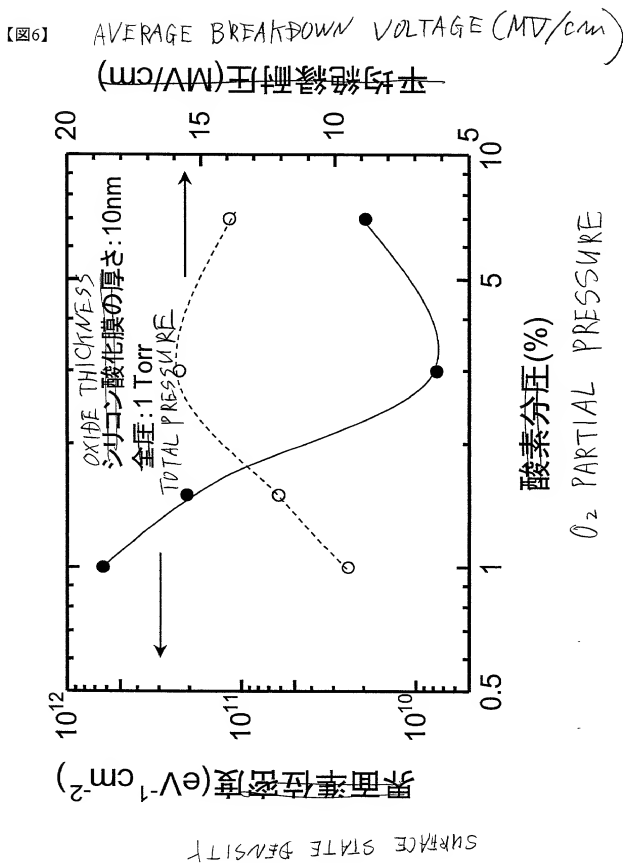


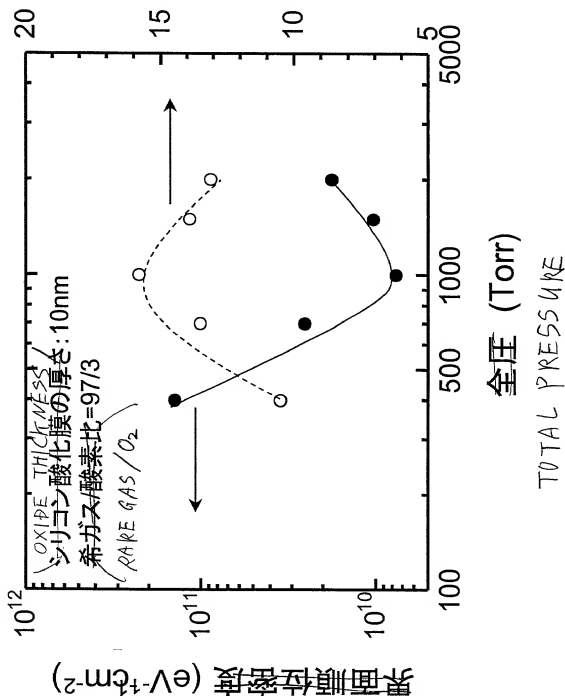
Fig 6



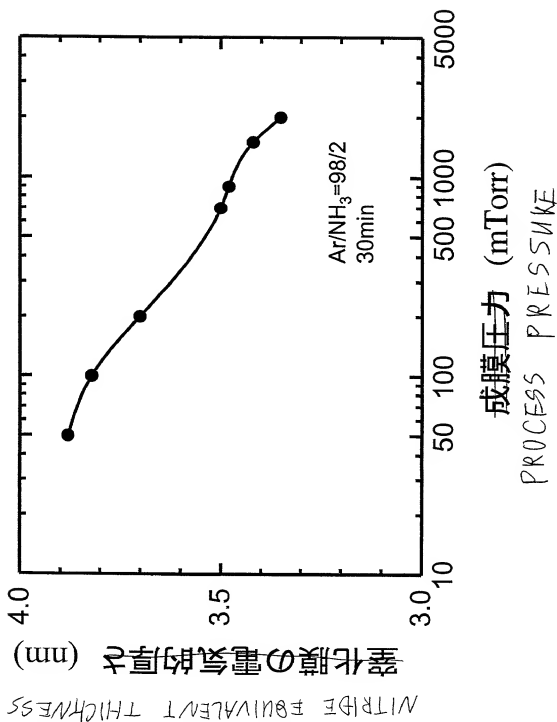
F167

【図7】

AVERAGE BREAKDOWN VOLTAGE (MV/cm)  
平均絶縁耐圧 (MV/cm)



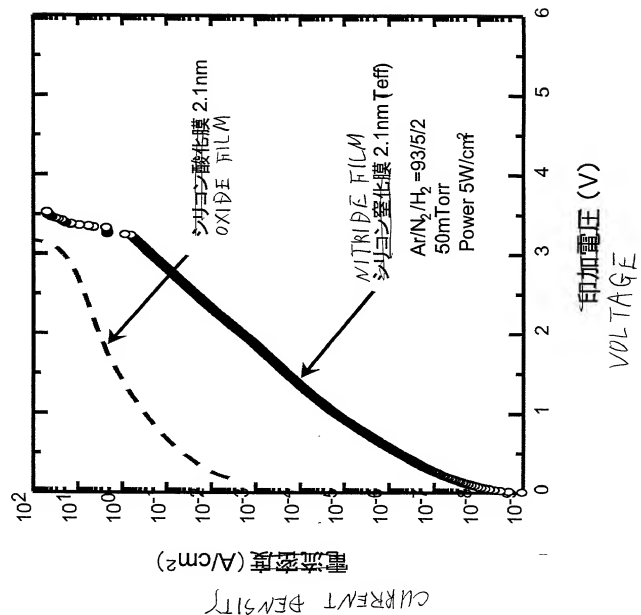
SURFACE STATE DENSITY



【図8】



FIG 9



【図9】

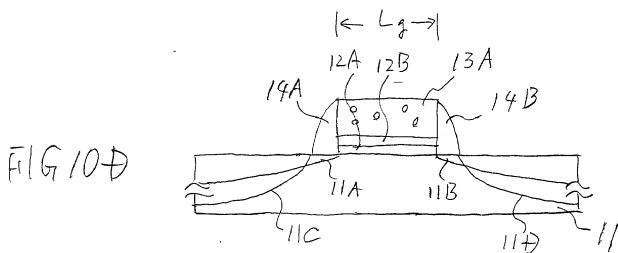
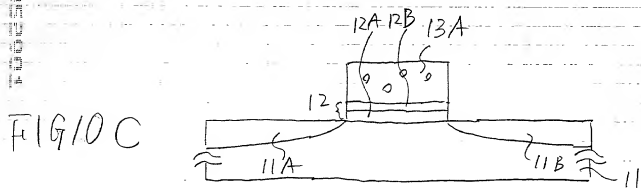
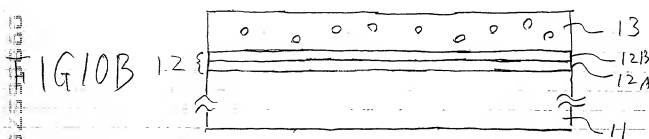
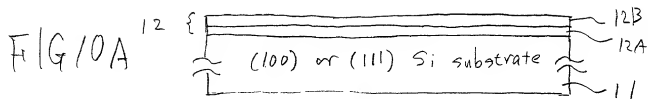


FIG. 10

【図10】

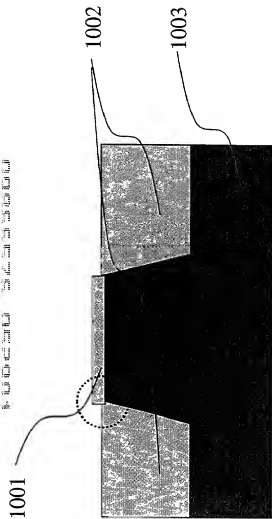


FIG 11A (a)



FIG 11B (b)

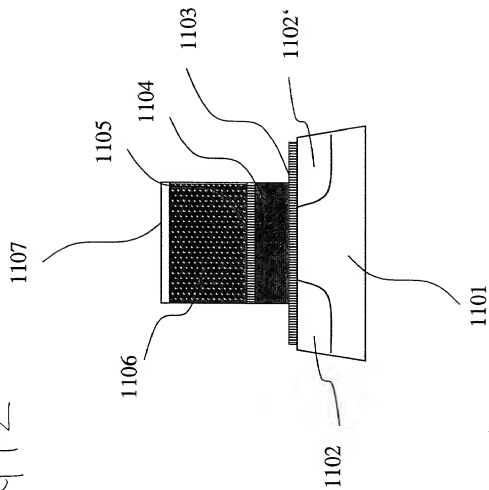
従来例



FIG 11C (c)

本発明 PRESENT INVENTION

FIG 12

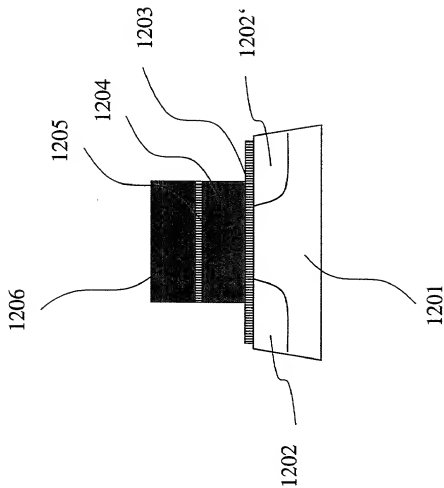


【图11】

FIG. 13

FIG. 13

【図12】



【図13】

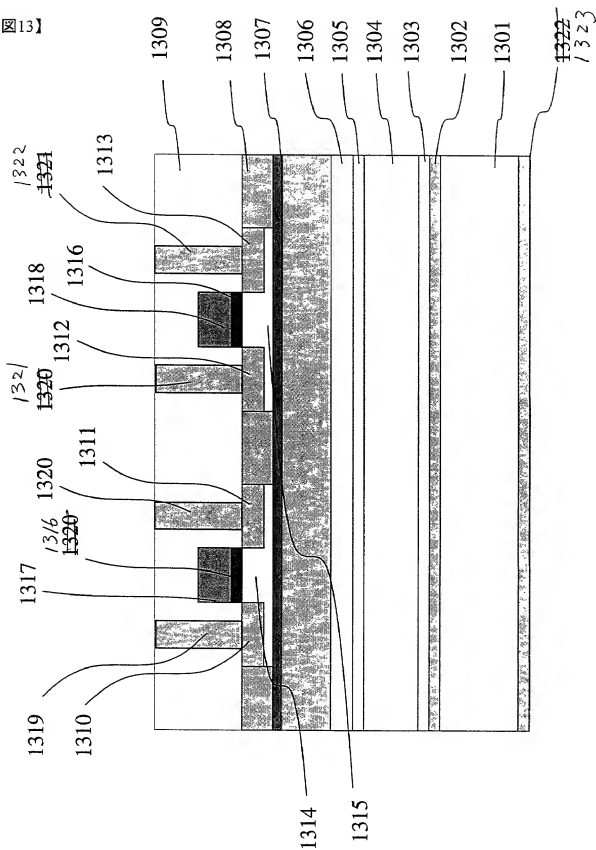
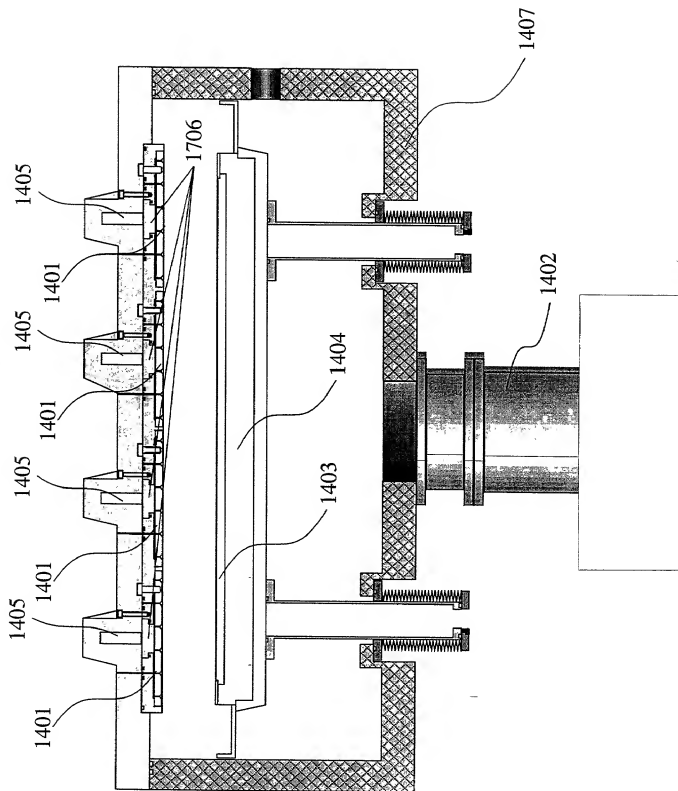
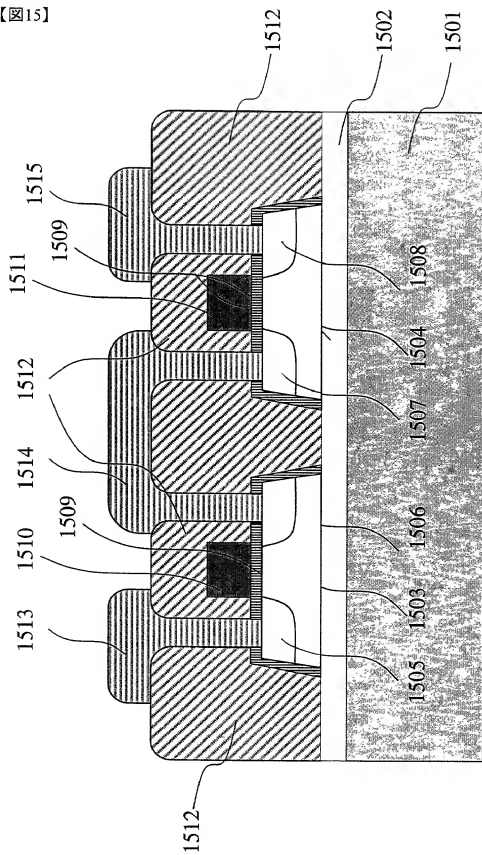


FIG. 15



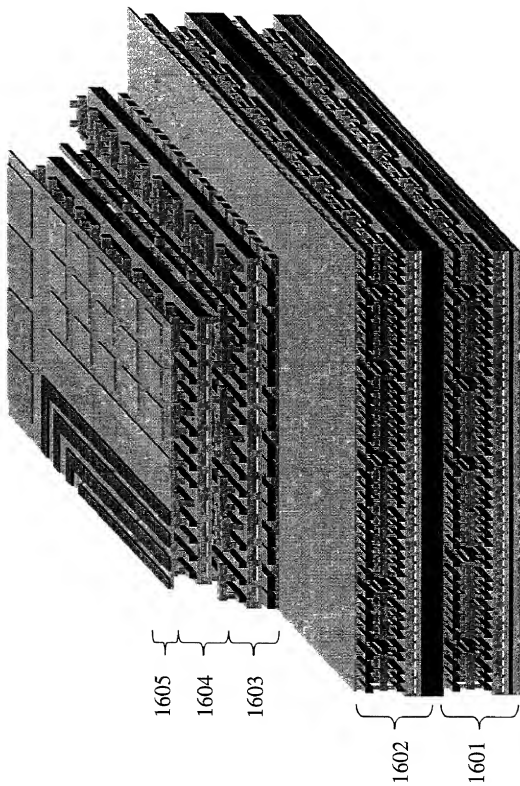
F/G16

【図15】





【図16】



2024/6/17